



## PATENT ABSTRACTS OF JAPAN

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the handle 18.

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**(57) Abstract:**

**PROBLEM TO BE SOLVED:** To provide a mounting apparatus for a leveler capable of mounting the leveler absorbing the delay in horizontal control of a rear cover against the field surface and performing a leveling work on the field surface, to a rotary in one action.

**SOLUTION:** This linking mechanism CS for a rear cover 6 and a leveler 7 has a locking mechanism LS working as follows: a rotary is provided with tilling tines 4 which is rotatably journaled to a shaft and the rear cover 6 for covering the backside of the tilling tines 4; the leveler 7 for leveling a field is attached on the rotary; a holding handle 18 is attached on the leveler; and the lock between the leveler 7 and the rear cover 6 is released by lifting the handle 18 holding the leveler 7, and the leveler 7 and the rear cover 6 are locked by freeing

